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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Kenichi WATANABE**

Group Art Unit: **2826**

Application Number: **10/622,614**

Examiner: **Alexander O. Williams**

Filed: **July 21, 2003**

Confirmation Number: **2630**

For: **SEMICONDUCTOR DEVICE FOR PREVENTING DEFECTIVE  
FILLING OF INTERCONNECTION AND CRACKING OF  
INSULATING FILM (AS AMENDED)**

Attorney Docket Number: **030877**  
Customer Number: **38834**

**RESPONSE TO QUAYLE ACTION**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

May 22, 2007

Sir:

This paper is filed in response to the Office Action dated April 18, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.